



GP 1765


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)	
)	
Wu et al.)	Group Art Unit: 1765
)	
Serial No.: 09/132,876)	Examiner: K. Chen
)	
Filed: August 11, 1998)	Docket No.: 252103-2040
)	
For: Chemical-Mechanical Polishing Method)	
)	

Certificate of Mailing

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Signature

AMENDMENT AND RESPONSE TO OFFICE ACTION

Assistant Commissioner of Patents
and Trademarks
Washington, D.C. 20231

Sir:

The Office Action mailed November 17, 1999 (Paper No. 3), has been carefully considered. In response thereto please enter the following amendments and consider the following remarks.

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TO 1765 UNIT 1765